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**CERTIFICATE OF FACSIMILE TRANSMISSION TO THE
UNITED STATES PATENT AND TRADEMARK OFFICE**

Date: June 1, 2006

United States Patent and Trademark Office : **RE: U.S. Patent Application Serial No.: 10/552,359**
Art Unit: 1774 : **Filing Date: October 3, 2005**
Fax: (571) 273-8300 : **Applicant: Hai Yu, et al.**
Examiner: TBA : **(AT File 20459-213)**
From: Phillip A. Shipley : **Atty. Dkt. No.: 16CN-G0304**

DOCUMENTS SUBMITTED WITH TRANSMISSION:
Request for Correction of Filing Receipt (1 pg.); Copy of Confirmation Filing Receipt (3 pgs.); & Certificate of Facsimile Transmission (1 pg.)

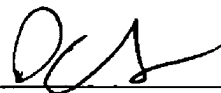
Total pages including cover page: 5
If all pages are not received, please contact: Sheryl at Ext. 7923

RE: The above referenced U.S. Patent Application
Title: MAGNETIC FIELD GENERATOR FOR MRI AND METHOD OF COVERING
MAGNETIC FIELD GENERATOR FOR MRI
Filed: October 3, 2005

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that these papers are being facsimile transmitted to the U.S. Patent and Trademark Office, Facsimile Number (571) 273-8300 on the date shown below.

Date: June 1, 2006


Phillip A. Shipley, Reg. No.: 51,357

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PATENT
Atty. Docket No. 16CN-G0304

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Hai Yu, et al.	:	
		:	Art Unit: 1774
Serial No.:	10/552,359	:	
		:	Examiner: TBA
Filed:	October 3, 2005	:	
		:	
For:	MAGNETIC FIELD GENERATOR FOR MRI	:	
	AND METHOD OF COVERING MAGNETIC	:	
	FIELD GENERATOR FOR MRI	:	

REQUEST FOR CORRECTED FILING RECEIPT

Via Facsimile Transmission

Mail Stop: Office of Initial Patent Examination
Attn: Filing Receipt Corrections
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants respectfully request that the filing receipt in the present application be corrected to set forth the correct resident city of Applicant William E-Wei-Chen and the PCT number under "Domestic Priority data." A copy of the Filing Receipt is attached reflecting the requested corrections, indicating the correct resident city of the aforementioned Applicant and the correct PCT number under "Domestic Priority data". The correct city of residence for Applicant William E-Wei Chen should be **Jiangsu** and the correct PCT number under "Domestic Priority data" should be **PCT/CN2003/000244**.

Applicants further request that a new, corrected filing receipt be issued.

Respectfully submitted,



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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/552,359	10/03/2005	1774	1100	16CN-G0304	8	20	4

CONFIRMATION NO. 7250

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FILING RECEIPT



OC000000018773716

Date Mailed: 05/12/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Domestic Priority data as claimed by applicant

This application is a 371 of PCT/~~EP~~ *CN2003/000244* 04/04/2003

Foreign Applications

Acceptable Request to Retrieve Priority Application Received?

Projected Publication Date: 08/17/2006

Non-Publication Request: No

Entered Into PAGE/PIPS

Date *5-25-06*

ENTERED
Date: *5/22/06*
By: *mcc*

20459-213

Early Publication Request: No**Title**

Magnetic field generator for mri and method of covering magnetic field generator for mri

Preliminary Class

428

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